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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

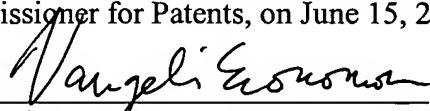
In re Application: Woo Seock CHEONG]
Serial No.: 10/034,228]
Filed: December 28, 2001]
For: METHOD OF MANUFACTURING A]
SEMICONDUCTOR DEVICE]

GRP ART UNIT: 2814

Ex.: Pham, Long

Certification under 37 C.F.R. §1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, on June 15, 2004.



Vangelis Economou - Reg. No. 32,341

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated March 29, 2004, please amend the above-identified application as follows:

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in this application: